



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

November 3, 2003

Applicant(s): Toshiaki MOTONAGA, et al
Inventor(s): HALFTONE PHASE SHIFTING PHOTOMASK AND BLANKS FOR
HALFTONE PHASE SHIFTING PHOTOMASK THEREFOR AND A
METHOD FOR FORMING PATTERN BY USING THE HALFTONE
PHASE SHIFTING PHOTOMASK

Serial No. : 09/825 578

Group: 1756

Confirmation No.: 9940

Filed : April 3, 2001

Examiner: S. Rosasco

Atty. Docket No.: OPS C-529

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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TC 1700

Sir:

Herewith is an amendment in the above-identified application.

☐ Applicant claims small entity status. See 37 CFR 1.27.☐ The additional filing fee has been calculated as shown below:

For	No. Filed	No. Extra	(X) LG Entity	RATE	() SM Entity	Fee
Basic Fee				\$770.00	\$385.00	\$0.00
Total Claims	(27 - 27 = 0)		x \$ 18.00		x \$ 9.00	0.00
Indep. Claims	(11 - 11 = 0)		x \$ 86.00		x \$ 43.00	0.00
[] Multiple Dep. Claim			+ \$290.00		+ \$145.00	0.00
* * * TOTAL FILING FEE * * *						\$ 0.00

☒ Pursuant to 37 CFR 1.136(a), please extend the shortened period for response by two (2) month(s). The extension fee is: \$420.00.

☒ A Check for \$420.00 is enclosed to cover fees.

☒ Please credit any overpayment, or charge any additional filing fee required under 37 CFR 1.16 or 1.17 by this communication, to Deposit Account No. 06-1382. A duplicate copy of this sheet is enclosed.

IN DUPLICATE

MLM\pcq

Mark L. Maki Reg. No. 36 589

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 3 2003

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Mark L. Maki